



Docket No.: 4249-0110P
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Ramam AKKIPEDDI et al.

Application No.: 10/602,714

Confirmation No.: 9942

Filed: June 25, 2003

Art Unit: 1765

For: METHOD OF CLEAVING GaN/SAPPHIRE
FOR FORMING LASER MIRROR FACETS

Examiner: S. Ahmed

AMENDMENT

MS RCE
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

INTRODUCTORY COMMENTS

Prior to further examination on the merits, please amend the above-identified U.S. patent application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 7 of this paper.